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PATENT
Customer No. 23494
Attorney Docket No. TI-31620
Application No.: 10/085,753

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TSUGA et al.) Group Art Unit: 1746
Application No.: 10/085,753) Examiner: Michael Kornakov
Filed: February 28, 2002)
For: METHOD AND DEVICE FOR)
REMOVING PARTICLES ON)
SEMICONDUCTOR WAFERS)

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three month extension of time to reply to the Office Action dated June 18, 2004, December 18 being a Saturday.

Please grant any extensions of time required to enter this response and charge any required fees to the Texas Instruments Incorporated Deposit Account 20-0668.

Respectfully submitted,

By: _____


Jonathan A. Hack
Reg. No. 47,623

Dated: December 20, 2004